

Laboratory Scale Star Shade Mask for Testing at Princeton University **Fabrication and Assessment of Petal Edge Accuracy and Defects** Direct Write Device DW#21 Fabrication Completion Date: Dec 26, 2018 Shipped to Princeton University on Jan 25, 2019

Bala K. Balasubramanian, Simon Vuong, Victor White, Karl Yee, Richard Müller Optics Section 383, Jet Propulsion Laboratory. Jan 25, 2019 © 2019 California Institute of Technology. Government sponsorship acknowledged



Starshade Device

Direct Write #21 (DW21)

- Design: Starshade_11_5_18_0.cif
- Device Fab Start Date: Nov 27, 2018
- Device Completion Date: Dec 26, 2018
- Imaging Dates: Dec 2018 Jan 2019
- Ship Date: 2019-01-25
- Starshade petals are numbered 1-16, with numbers incrementing clockwise about the device when viewed from front (gold coated) side up.



Starshade Device

Direct Write #21 (DW21)

- Full-scan mosaic stitched from 2.5x Transmission and Reflection Objective images.
- File name:

Fullscan_DW21_2.5x_10percentResize (pixel size: 13.54 µm/pixel after rescaling)



Top Layer Average Thickness

Direct Write #21 (DW21)





Direct Write #21 (DW21)

- Series of images taken with 10x Objective in Transmission and Reflection
- Pixel size: 0.34 µm/pixel
- A total of 64 images are taken along the contour of Petal 1 and assembled
- Directory: .../Individual Microscope Images/Petal 1
- File format: 20181227_DW21_P1_10xTxRx_****
- Petal 1 tip measurement (next slide)



Starshade Lab Scale Mask - Report on Direct Write #21 Characteristics & Defects

Petal 1 – Tip measurement

Direct Write #21 (DW21)



◄ Inner Tip

Design file spec. = $16.72 \ \mu m$ RMS edge roughness = $15.6 \ nm$ peak-to-peak edge roughness = $44.3 \ nm$

Outer Tip ► Design file spec. = 27.85 µm RMS edge roughness = 8.3 nm Peak-to-peak edge roughness = 70 nm



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Direct Write #21 (DW21)

- Series of images taken with 10x Objective in Transmission and Reflection
- Pixel size: 0.34 µm/pixel
- A total of 65 images are taken along the contour of Petal 2 and assembled
- Directory: .../Individual Microscope Images/Petal 2
- File format: 20181227_DW21_P2_10xTxRx_****



Direct Write #21 (DW21)

- Series of images taken with 10x objective in Transmission and Reflection
- Pixel size: 0.34 µm/pixel
- A total of 65 images are taken along the contour of Petal 3 and assembled
- Directory: .../Individual Microscope Images/Petal 3
- File format: 20181227_DW21_P3_10xTxRx_****



Green Areas : Petal openings in Transmission

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Direct Write #21 (DW21)

- Series of images taken with 10x Objective in Transmission and Reflection
- Pixel size: 0.34 µm/pixel
- A total of 65 images are taken along the contour of Petal 4 and assembled
- Directory: .../Individual Microscope Images/Petal 4
- File format: 20181227_DW21_P4_10xTxRx_****

Green Areas : Petal openings in Transmission

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Direct Write #21 (DW21)

- Series of images taken with 10x
 Objective in Transmission and Reflection
- Pixel size: 0.34 µm/pixel
- A total of 64 images are taken along the contour of Petal 5 and assembled
- Petal 5 tip measurement (next slide)

- Directory: .../Individual Microscope Images/Petal 5
- File format: **20181227_DW21_P5_10xTxRx_******



Starshade Lab Scale Mask - Report on Direct Write #21 Characteristics & Defects

Petal 5 – Tip measurement

Direct Write #21 (DW21)



◄ Inner Tip

Design file spec. = 16.72 µm RMS edge roughness = 16.1 nm Peak-to-peak edge roughness = 77.5 nm

Outer Tip ► Design file spec. = 27.85 µm RMS edge roughness = 19 nm Peak-to-peak edge roughness = 71.5 nm



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Direct Write #21 (DW21)

- Series of images taken with 10x Objective in Transmission and Reflection
- A total of 65 images are taken along the contour of Petal 6 and assembled

• Directory: .../Individual Microscope Images/Petal 6

• File format: 20181227_DW21_P6_10xTxRx_****



Direct Write #21 (DW21)

- Series of images taken with 10x Objective in Transmission and Reflection
- Pixel size: 0.34 µm/pixel
- A total of 65 images are taken along the contour of Petal 7 and assembled
- Directory: .../Individual Microscope
 Images/Petal 7
- File format: 20181227_DW21_P7_10xTxRx_****



Direct Write #21 (DW21)

- Series of images taken with 10x Objective in Transmission and Reflection
- Pixel size: 0.34 µm/pixel
- A total of 64 images are taken along the contour of Petal 8 and assembled
- Directory: .../Individual Microscope Images/Petal 8
- File format: 20181227_DW21_P8_10xTxRx_****



Direct Write #21 (DW21)

- Series of images taken with 10x Objective in Transmission and Reflection
- Pixel size: 0.34 µm/pixel
- A total of 64 images are taken along the contour of Petal 9 and assembled
- Directory: .../Individual Microscope Images/Petal 9
- File format: 20181227_DW21_P9_10xTxRx_**** (see figure for number legend)
- Petal 9 tip measurement

(next slide)



Petal 9 – Tip measurement

Direct Write #21 (DW21)



◄ Inner Tip

RMS edge roughness = 19.1 nmPeak-to-peak edge roughness = 88.5 nmDesign file spec. = $16.72 \mu \text{m}$

Outer Tip ►



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Direct Write #21 (DW21)

- Series of images taken with 10x Objective in Transmission and Reflection
- Pixel size: 0.34 µm/pixel
- A total of 65 images are taken along the contour of Petal 10 and assembled
- Directory: .../Individual Microscope Images/Petal 10
- File format: 20181227_DW21_P10_10xTxRx_**** (see figure for number legend)



Direct Write #21 (DW21)

- Series of images taken with 10x Objective in Transmission and Reflection
- Pixel size: 0.34 µm/pixel
- A total of 65 images are taken along the contour of Petal 11 and assembled
- Directory: .../Individual Microscope **Images/Petal 11**
- File format: 20181227_DW21_P11_10xTxRx_****





Direct Write #21 (DW21)

- Series of images taken with 10x Objective in Transmission and Reflection
- Pixel size: 0.34 µm/pixel
- A total of 65 images are taken along the contour of Petal 12 and assembled

- Directory: .../Individual Microscope Images/Petal 12
- File format: 20181227_DW21_P12_10xTxRx_****



Direct Write #21 (DW21)

- Series of images taken with 10x Objective in Transmission and Reflection
- Pixel size: 0.34 µm/pixel
- A total of 64 images are taken along the contour of Petal 13 and assembled
- Petal 13 tip measurement (next slide)

- Directory: .../Individual Microscope Images/Petal 13
- File format: 20181227_DW21_P13_10xTxRx_****



Petal 13 – Tip measurement

Direct Write #21 (DW21)



◄ Inner Tip

RMS edge roughness = 19.2 nmPeak-to-peak edge roughness = 74.5 nmDesign file spec. = $16.72 \mu \text{m}$

Outer Tip ►



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Direct Write #21 (DW21)

- Series of images taken with 10x Objective in Transmission and Reflection
- Pixel size: 0.34 µm/pixel
- A total of 65 images are taken along the contour of Petal 14 and assembled

Directory: .../Individual Microscope Images/Petal 14 •

File format: 20181227_DW21_P14_10xTxRx_****



Direct Write #21 (DW21)

- Series of images taken with 10x Objective in Transmission and Reflection
- Pixel size: 0.34 µm/pixel
- A total of 65 images are taken along the contour of Petal 15 and assembled
- Directory: .../Individual Microscope Images/Petal 15
- File format: 20181227_DW21_P15_10xTxRx_****



Direct Write #21 (DW21)

- Series of images taken with 10x Objective in Transmission and Reflection
- Pixel size: 0.34 µm/pixel
- A total of 64 images are taken along the contour of Petal 16 and assembled
- Directory: .../Individual Microscope Images/Petal 16
- File format: 20181227_DW21_P16_10xTxRx_****





Starshade Device

Direct Write #21 (DW21)

- Mosaic stitched from all 10x Transmission and Reflection Objective images (along the contour of the mask)
- File name: .../Mosaics/DW21_Full
- Mosaics of each petals are also found in the same folder



Defects Statistics / Diagram

Direct Write #21 (DW21)

Defect No.	Petal No.	Image No.	Defect area (µm²)	
1	10	13	16.58	
2	11	35	19.97	
3	15	1	~ 0	
4	15	3	5.67	
5	16	5	8.54	
6	3	61	1.51	
7	5	9	80.49	
8	8	1 5.75		
9	9	18	41.14	

e.g. The 10x Image containing Defect #1 is found at .../Individual Microscope Images/Petal 10/20181227_DW21_P10_10xTxRx_0013.tif



Defect #1 Direct Write #21 (DW21)



Defect #01 Petal 10 | Im #13 (-3071.32, -14245.32) μ m A \approx 16.58 μ m²



Defect #2 Direct Write #21 (DW21)



Defect #02 Petal 11 | Im #35 (-18318.58, -18384.80) μm $A\approx 19.97~\mu\text{m}^2$



Defect #3 Direct Write #21 (DW21)







Defect #4 Direct Write #21 (DW21)



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Defect #04
   Petal 15 | Im #3
*
   ( -6995.94, 6613.63 ) μm
   A \approx 5.67 \, \mu m^2
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Defect #5 Direct Write #21 (DW21)



Defect #05 Petal 16 | Im #5 (-4866.18, 9521.52) μm $A \approx 8.54 \ \mu m^2$



Defect #6 Direct Write #21 (DW21)



Defect #06

Petal 3 | Im #61 (9163.04, 6621.95) µm A \approx **1.51** µm²



Defect #7 Direct Write #21 (DW21)



$\begin{array}{c} \textbf{Defect \#07} \\ \textbf{Petal 5 | Im \#9} \\ \textbf{(11927.70, 2185.92)} \ \textbf{\mu m} \end{array} \end{array}$

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Defect #8 Direct Write #21 (DW21)



Defect #08 Petal 8 | Im #1

(2929.22, -7732.09) μm $^{\circ}$ A \approx 5.75 μm²

Defect #9 Direct Write #21 (DW21)







Defects Statistics

Direct Write #21 (DW21)

Defect No.	Petal No.	Image No.	Χ (μm)	Υ (μm)	Distance to Spine (µm)	Distance from Inner Tip (µm)	Area (µm²)
1	10	13	3071.32	14245.32	3071.32	40057.64	16.58
2	11	35	18318.58	18384.80	18318.58	44197.11	19.97
3	15	1	5791.22	-5498.55	5791.22	20313.76	~ 0
4	15	3	6995.94	-6613.63	6995.94	19198.69	5.67
5	16	5	4866.18	-9521.52	4866.18	16290.79	8.54
6	3	61	-9163.04	-6621.95	9163.04	19190.36	1.51
7	5	9	-11927.70	-2185.92	11927.70	23626.40	80.49
8	8	1	-2929.22	7732.09	2929.22	33544.41	5.75
9	9	18	-2803.25	17155.53	2803.26	42967.85	41.14

With (0, 0) being the center of the starshade mask

[not the Wafer]



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